



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

TAKENO

Attorney Docket No: 107242-00024

Application No. 09/926,202

Art Unit: 1765

Filed: September 24, 2001

Examiner: M. Anderson

For: MANUFACTURING PROCESS FOR SILICON EPITAXIAL WAFER

**REQUEST FOR RECONSIDERATION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

June 20, 2003

Sir:

In reply to the Office Action dated March 25, 2003, please consider the following remarks during the prosecution of the above-identified application:

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JUN 24 2003  
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